To: Commissioner of Patents and Trademarks Washington, D.C. 20231

Fr: George O. Saile

Reg. No. 19,572

28 Davis Avenue

Poughkeepsie, N.Y. 12603

Subject:

Divisional Patent Application of

Serial No.: 09/636,580 8/10/00

SIMON CHOOI, YAKUB ALIYU, MEI-SHENG ZHOU, JOHN SUDIJONO, SUBHASH GUPTA, SUDIPTO

ROY, PAUL HO, XU YI

METHOD TO CREATE A COPPER DIFFUSION

DETTERENT INTERFACE

PRELIMINARY AMENDMENT

Dear Sir:

This is a preliminary amendment for the above referenced Divisional Patent

Application. Please amend the above identified application for patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on November 21, 2003.

Stephen B. Ackerman, Reg. No. 37,761

Signature/Date

PLEASE AMEND THE SPECIFICATION AS FOLLOWS:

After the title, insert -- This is a division of Patent Application serial number 09/636,580, filing date 8/10/00, Method To Create A Copper Diffusion Detterent Interface, assigned to the same assignee as the present invention.

REMARKS

A reference to the parent case has been added by Preliminary Amendment to this Divisional Patent Application.

The application is believed to be in condition for allowance. Allowance of the subject Patent Application is therefore respectfully requested.

Respectfully submitted,

STEPHEN B. ACKERMAN, REG. NO. 37,761